Light Source Design – Part 1: Parameters, Metrics and Configurations

Monday 22 Nov 2010 at 15:30 (00h50')

Primary authors : Dr. HETTEL, Robert (SLAC)

Co-authors :

Presenter : Dr. HETTEL, Robert (SLAC)

Light Source Design: Storage Ring Technology

(SPEAR3 and elsewhere)

Robert Hettel, SLAC Mexican Light Source Workshop November 22-24, 2010





Topics Discussed

- Parameter choices
- Lattice types
- SPEAR3 accelerator physics studies
- Magnets and girders
- Vacuum system
- Power supplies
- RF systems
- Instrumentation and controls
- Photon beam line components
- Insertion devices





Topics Not Discussed

- Injector design
- Kicker magnets and pulsers
- Synchrotron light monitors
- Photon BPMs and misc. other diagnostics
- Transverse/Longitudinal Feedback Systems
- Machine Protection Systems
- Personnel Protection Systems
- Beam Containment Systems
- Radiation shielding
- Tunnel and experimental floor engineering
- Utilities (gasses, water, electricity)





Basic Storage Ring Parameters

- Energy
 - critical photon energy ~ E^2
 - photon power density ~ E^4
 - ring circumference ~ E
- Current

- photon flux density ~ E^2
- RF voltage ~ E4/ ρ

cost

- Beam power ~ I (absorber and optics design, RF power)
- Brightness and flux ~ I
- Beam dimensions (size, divergence, bunch length) emittance





Basic Storage Ring Parameters

- Energy
 - critical photon energy ~ E^2
 - photon power density ~ E^4
 - ring circumference ~ E
- Current

- photon flux density $\sim E^2$
- RF voltage ~ E^4/ρ

cost

- Beam power ~ I (absorber and optics design, RF power)
- Brightness and flux ~ I
- Beam dimensions (size, divergence, bunch length) emittance
- Site dimensions (available space, cost)
- Number of bend magnet vs. insertion device beam lines
- Number and length of straight sections (for IDs, injection, RF)
- Injector type (linac, booster, top-up capability, cost)
- Other requirements and constraints





Light Source Design







draft

Management assures options fully considered and optimal choices are made

NOT EASY!





 Management assures options fully considered and optimal choices are made

NOT EASY!





Management assures options fully considered and optimal choices are made

NOT EASY!

- **m** Criteria for making design choices:
 - performance

 \cdot technical risk





Management assures options fully considered and optimal choices are made

NOT EASY!

- performance
- reliability/maintainability

- \cdot technical risk
- · cost and schedule





Management assures options fully considered and optimal choices are made

NOT EASY!

- performance
- reliability/maintainability
- personalities, group relationships
- \cdot technical risk
- $\cdot\,$ cost and schedule
- \cdot etc.





Management assures options fully considered and optimal choices are made

NOT EASY!

- performance
- reliability/maintainability
- personalities, group relationships
- **Methods for making design choices:**

- · technical risk
- $\cdot\,$ cost and schedule
- \cdot etc.





• Management assures options fully considered and optimal choices are made

NOT EASY!

- performance
- reliability/maintainability
- personalities, group relationships etc.
- Methods for making design choices:
 - clear specification of performance requirements

- technical risk
- cost and schedule





Management assures options fully considered and optimal choices are made

NOT EASY!

m Criteria for making design choices:

- performance
- reliability/maintainability
- personalities, group relationships •

Methods for making design choices:

- clear specification of performance requirements
 - written by accelerator physicists, beam line users, expert engineers, etc.



technical risk

- $\cdot\,$ cost and schedule
- \cdot etc.

Management assures options fully considered and optimal choices are made

NOT EASY!

technical risk

cost and schedule

m Criteria for making design choices:

- performance
- reliability/maintainability
- personalities, group relationships etc.

Methods for making design choices:

- clear specification of performance requirements
 - written by accelerator physicists, beam line users, expert engineers, etc.
 - convene workshop as needed (e.g. 3 vs. 3.5 GeV decision for SPEAR 3)





Management assures options fully considered and optimal choices are made

NOT EASY!

technical risk

cost and schedule

m Criteria for making design choices:

- performance
- reliability/maintainability
- personalities, group relationships etc.

Methods for making design choices:

- clear specification of performance requirements
 - written by accelerator physicists, beam line users, expert engineers, etc.
 - convene workshop as needed (e.g. 3 vs. 3.5 GeV decision for SPEAR 3)
- discussion of options





• Management assures options fully considered and optimal choices are made

NOT EASY!

Criteria for making design choices:

- performance
- reliability/maintainability
- personalities, group relationships etc.

Methods for making design choices:

- clear specification of performance requirements
 - written by accelerator physicists, beam line users, expert engineers, etc.
 - convene workshop as needed (e.g. 3 vs. 3.5 GeV decision for SPEAR 3)
- discussion of options
 - solutions need to be compatible, not interfere with other systems
- internal and external design reviews
- parallel/competitive design of critical systems best solution adopted





cost and schedule

technical risk

Energy





Energy vs. Current

Radiated photon power and power density ~ $E^4 I/\rho$

For a ring having fixed circumference (ρ) and photon absorbers operating near maximum rating, or for fixed available RF power:

 $E^4 I/\rho = constant$

SPEAR3: 3 GeV @ 500 mA vs. 3.5 GeV @ 280 mA bend magnet intensity vs. SPEAR energy 1013 3 (-) vs 3.5 (--) , 2m device, 200 mA vs 120 mA 3 2







Electron Beam Dimensions

e- beam size:

$$\sigma_{x}(s) = \sqrt{\varepsilon_{x}\beta_{x}(s) + (\eta(s)\sigma_{Ee^{-}}/E_{e^{-}})^{2}} \qquad \sigma_{y}(s) = \sqrt{\varepsilon_{y}\beta_{y}(s)}$$

e- divergence:

$$\sigma_{x'}(s) = \sqrt{\varepsilon_x \gamma_x(s) + (\eta'(s)\sigma_{Ee^-} / E_{e^-})^2} \qquad \sigma_{y'}(s) = \sqrt{\varepsilon_y \gamma_y(s)}$$

$$\varepsilon_{y} = \kappa \varepsilon_{x}$$

Dimensions depend on ϵ , Twiss parameters (β , η , etc), coupling κ (need good coupling correction)





Photon Spectral Brightness

Spectral brightness: photon density in 6D phase space

$$\mathsf{B}_{\mathsf{avg}}(\lambda) \propto \frac{\mathsf{N}_{\mathsf{ph}}(\lambda)}{(\epsilon_{\mathsf{x}} \oplus \epsilon_{\mathsf{r}}(\lambda))(\epsilon_{\mathsf{y}} \oplus \epsilon_{\mathsf{r}}(\lambda))(\mathsf{s} \times \mathsf{W}\mathsf{B}\mathsf{W})}$$

 $\varepsilon_{x,y}$ = electron emittance

 ε_r = photon emittance = $\lambda/4\pi$

$$B_{pk}(\lambda) \propto \frac{N_{ph}(\lambda)}{(\varepsilon_{x} \oplus \varepsilon_{r}(\lambda))(\varepsilon_{y} \oplus \varepsilon_{r}(\lambda))(\sigma_{t} \not\sim BW)}$$
$$\sigma_{t} = \text{bunch length}$$





Photon Spectral Brightness

Spectral brightness: photon density in 6D phase space

$$\mathsf{B}_{\mathsf{avg}}(\lambda) \propto \frac{\mathsf{N}_{\mathsf{ph}}(\lambda)}{(\varepsilon_{\mathsf{x}} \oplus \varepsilon_{\mathsf{r}}(\lambda))(\varepsilon_{\mathsf{y}} \oplus \varepsilon_{\mathsf{r}}(\lambda))(\mathsf{s} \times \mathsf{W}\mathsf{B}\mathsf{W})}$$

 $\varepsilon_{x,y}$ = electron emittance

 ε_r = photon emittance = $\lambda/4\pi$

$$B_{pk}(\lambda) \propto \frac{N_{ph}(\lambda)}{(\varepsilon_{x} \oplus \varepsilon_{r}(\lambda))(\varepsilon_{y} \oplus \varepsilon_{r}(\lambda))(\sigma_{t} \times BW)}$$
$$\sigma_{t} = \text{bunch length}$$

Coherent fraction:

$$f_{coh}(\lambda) = \frac{\lambda/4\pi}{(\epsilon_x \oplus \epsilon_r(\lambda))} \times \frac{\lambda/4\pi}{(\epsilon_y \oplus \epsilon_r(\lambda))}$$





Storage Ring Emittance

Emittance ε_x results from the balance between radiation excitation S_x and damping τ_x :

$$\varepsilon_{x} = S_{x}\tau_{x}$$

$$S_{x} \approx E^{5} \oint B^{3}(s) \mathbf{H}(s) ds$$

$$\frac{1}{\tau_{x}} \approx J_{x}E^{3} \oint B^{2}(s) ds$$

$$\mathbf{H}(s) = \eta_{x}^{2}(s) + \frac{\left(\beta_{x}(s)\eta_{x}'(s) - \frac{\beta_{x}'(s)}{2}\eta_{x}(s)\right)^{\frac{1}{2}}}{\beta_{x}(s)}$$

- E = electron energy B = vertical magnetic field strength
- β_x , η_x = Twiss parameters; $\beta_x' = d\beta_x/ds$, $\eta_x' = d\eta_x/ds$ J_x = horizontal damping partition number (~ 1)





Minimizing Emittance

$$\varepsilon_{x0} = \frac{C_q E^2}{J_x} \Theta^3 F_{latt}$$

 θ = dipole bend angle

F_{latt} depends on lattice type and is minimum for Theoretical Minimum Lattice (TME)

$$F_{latt}(TME) = \frac{1}{12\sqrt{15}}$$





Minimizing Emittance

$$\varepsilon_{x0} = \frac{C_q E^2}{J_x} \theta^3 F_{latt}$$

 θ = dipole bend angle

F_{latt} depends on lattice type and is minimum for Theoretical Minimum Lattice (TME)

$$F_{latt}(TME) = \frac{1}{12\sqrt{15}}$$







Minimizing Emittance

$$\varepsilon_{x0} = \frac{C_q E^2}{J_x} \theta^3 F_{latt}$$

 θ = dipole bend angle

F_{latt} depends on lattice type and is minimum for Theoretical Minimum Lattice (TME)

$$F_{latt}(TME) = \frac{1}{12\sqrt{15}}$$



For a given lattice type: $\epsilon_x \sim C^{-3}$, C = ring circumference





Electron-photon phase space matching:







Electron-photon phase space matching:



Phase space matching normally reduces to minimizing $\beta_{\textbf{x}}$ in ID straights for minimum beam size.





Electron-photon phase space matching:



Phase space matching normally reduces to minimizing $\beta_{\textbf{x}}$ in ID straights for minimum beam size.

But $\beta_{\textbf{x}}$ in injection straight must be large to maximize injection acceptance.





Electron-photon phase space matching:



Phase space matching normally reduces to minimizing $\beta_{\textbf{x}}$ in ID straights for minimum beam size.

But β_x in injection straight must be large to maximize injection acceptance.

Can reach minimum ID gap when vertical beam size at ID entrance/exit is minimized:

$$\beta_{y}(s=0) = \frac{L_{ID}}{2}$$







Light Source Parameters

Facility	Energy (GeV)	Circumf (m)	Lattice	# straight sections	Emittance (nm-rad)	Current (mA)
ANKA	2.5	103.2	DDBA	4 4 / 7 m	88/45	200 (400)
SESAME	2.5	124.8	"TME Optic"	16 3 / 3.2 m	24.6 w/o IDs	400
NSLS-I	2.8	170.1	(Chasman/Green) DBA	8 4.5 m	90/45	280
CLS	3	170.9	DBA	12 5 m	18	280
ASP	3	216	DBA	14 5 m	16	200
SPEAR3	3	234.8	DBA	18 3 / 4 / 7m	18/9.8	500
PLS-II	3	281.8	Split DBA	20 3.1 / 6.9 m	5.8/<10 with IDs	400
ALBA	3	268.8	DBA	16 2.6/4.2/8 m	4.3	400

NATIONAL ACCELERATOR LABORATORY

Light Source Parameters – cont.

Facility	Energy (GeV)	Circumf (m)	Lattice	# straight sections	Emittance (nm-rad)	Current (mA)
SLS	2.4	288	TBA	12 4/7/11 m	4.8/4.1	400
Soleil	2.75	354.1	Mod Chas Green	24 3.8/7/12 m	3.7	500
Diamond	3	561.6	DBA	24 5 / 8 m	2.7	300
TPS	3	518.4	DBA	24 7/12 m	1.6	400
LNLS2	3	332	TBA	16 7 m	0.84 (DW)	500
NSLS-II	3	792	DBA	30 6.6 / 9.3 m	0.6 (DW)	500
MAX-IV	3	528	7BA	20 5 m	0.26 (DW)	500
PEP-X	4.5	2200	TME/DBA	32+ 4 /100 m	~0.03	200

NATIONAL ACCELERATOR LABORATORY

Booster-Ring Configurations





Booster-Ring Configurations









Booster-Ring Configurations



ring energy-ramp






Booster-Ring Configurations



At-Energy Linac Injector







Storage Ring Lattice Types



Double-Bend Achromat (DBA)





Storage Ring Lattice Types



SPEAR3 – gradient dipole













Åfter

Before

emittance growth with IDs

ACCELERATOR

LABORATOR



20

Sextupole

3.4 m

3.1 m Quadrupole

Bend

6.86 m

6.86 m



Multiple-bend achromat (MBA)











Dispersion Leak to Reduce Emittance

Ś



Figure 2. Machine functions in the original lattice.



Figure 3. Machine functions in the low emittance lattice.

$$\begin{split} & \varepsilon_{x} = S_{x}\tau_{x} \\ & S_{x} \approx E^{5} \oint B^{3}(s)\mathcal{H}(s)ds \\ & \frac{1}{\tau_{x}} \approx J_{x}E^{3} \oint B^{2}(s)ds \\ & \mathcal{H}(s) = \eta_{x}^{2}(s) + \frac{\left(\beta_{x}(s)\eta_{x}'(s) - \frac{\beta_{x}'(s)}{2}\eta_{x}(s)\right)^{2}}{\beta_{x}(s)} \end{split}$$





SPEAR3 Design









SPEAR3 Lattice Replacement



SPEAR3 Lattice Replacement



SPEAR3 Upgrade - Summary

	SPEAR 2	SPEAR 3	
Energy	3 GeV	3 GeV*	
Emittance (with IDs)	160 nm-rad	16 nm-rad	← 9.5 nm-rad with dispersion leal
Current	100 mA	500 mA**	
Lifetime	40 h@ 100 mA	>10 h@ 500 mA	
Critical energy	4.8 keV	7.6 keV	
Circumference	234.126 m	234.126 m	
RF frequency/ h	358.5 MHz/280	476.3 MHz/372	
Injection energy	2.3 GeV	3 GeV	

* 3.3 GeV maximum energy, with current limited to 330 mA.
** 100 mA limit for some beam lines until upgraded for 500 mA.





SPEAR3 Upgrade - Summary

1	SPEAR 2	SPEAR 3	
Energy	3 GeV	3 GeV*	
Emittance (with IDs)	160 nm-rad	16 nm-rad	← 9.5 nm-rad with dispersion leak
Current	100 mA	500 mA**	
Lifetime	40 h@ 100 mA	>10 h@ 500 mA	
Critical energy	4.8 keV	7.6 keV	
Circumference	234.126 m	234.126 m	
RF frequency/ h	358.5 MHz/280	476.3 MHz/372	
Injection energy	2.3 GeV	3 GeV	

* 3.3 GeV maximum energy, with current limited to 330 mA.** 100 mA limit for some beam lines until upgraded for 500 mA.

- Beam line alignment unchanged
- Low impedance, stable vacuum chamber
- < 1.6 nTorr N₂-equivalent pressure at 500 mA



- Mode-damped RF system
- Stable beam properties
- Minimal down time for users (< 1 year)



SPEAR3 Beam Dimensions

	ID Sour	ce Point	Dipole Source Point		
	SPEAR 2	SPEAR 3	SPEAR 2	SPEAR 3	
σ _x	2000 µm	427 ^μ m	790 µ _m	160 ^µ m	
σ _{x'}	2-20 mrad	2-20 mrad*	mrads	mrads	
σ	53 μ _m	30 ^µ m	200 µm	50 μm	
σ _{y'}	142 ^µ rad	136 ^µ rad*	147 ^µ rad	136 ^µ rad	
σ_{s}	23 mm/75 ps	5.3 mm/19 ps	23 mm/75 ps	5.3 mm/19 ps	

* For 100-period undulator: $\sigma_{x'} = 42 \ \mu_{rad}, \sigma_{y'} = 15 \ \mu_{rad}$





SPEAR3 Beam Dimensions

	ID Sour	ce Point	Dipole Source Point		
	SPEAR 2	SPEAR 3	SPEAR 2	SPEAR 3	
$\sigma_{\mathbf{x}}$	2000 µm	427 μm	790 ^µ m	160 ^µ m	
σ _{x'}	2-20 mrad	2-20 mrad*	mrads	mrads	
$\sigma_{\mathbf{y}}$	53 µ _m	30 µm	200 µm	50 μm	
σ _{y'}	142 ^µ rad	136 ^µ rad*	147 ^µ rad	136 ^µ rad	
$\sigma_{\mathbf{s}}$	23 mm/75 ps	5.3 mm/19 ps	23 mm/75 ps	5.3 mm/19 ps	

* For 100-period undulator: $\sigma_{x'} = 42 \ \mu_{rad}, \sigma_{y'} = 15 \ \mu_{rad}$

Transverse Stability:

<10% of beam dimensions

- \Rightarrow < 20 μm H, < 5 μm V at stable BPMs
- <1.4 µrad vertical for 100-period ID

 \Rightarrow < 0.02% coherent E oscillations (dipole sources)

Longitudinal Stability:

< 0.01% coherent E oscillations ($\Delta \phi < 0.3^{\circ}$) for 10⁻⁴ stability of 5th undulator harmonic



SPEAR 3 Photon Beam Improvements

	flux		brightness	
beam line	1keV	10keV	1keV	10keV
bend	4.7x	9.9x	89x	188x
BL4/7 ID	13.9x	15.3x	116x	127x
BL9 ID	5x	5x	43x	43x



BL9-2 (1mr accept)





SPEAR 3 Photon Beam Spectra





Work Breakdown Structure and Cost Estimate

1	SPEAR 3 Project	<u>M\$</u>	<u>M\$</u>
1.1	Magnet and Supports	6.7	
1.2	Vacuum System	9.1	
1.3	Power Supply System	3.5	
1.4	RF System	0.6	3.1
1.5	Instrumentation, Control and Protection Systems	2.6	
1.6	Injector	0.2	
1.7	Beam line Front Ends	1.0	
1.8	Facilities	1.3	
1.9	Installation and Alignment	4.0	
1.A	Project Physics, Management and Administration	2.7	
	Total Direct in FY'98M\$	31.6	34.1
	Indirect Costs	4.7	5.1
	Contingency	9.6	10.3
	Escalation	3.3	3.6
	TOTAL ESTIMATED COSTS (TEC)	/10 2	53 1





Accelerator Physics Studies

- 3.1 Storage Ring Lattice and Beam Parameters
 - 3.1.1 Storage Ring Geometry
 - 3.1.2 Standard Cells
 - 3.1.3 Matching Cells
 - 3.1.4 Storage Ring Lattice
 - 3.1.5 Electron Beam Parameters
 - 3.1.6 Photon Beam Parameters
 - 3.1.7 Single Particle Dynamics
 - 3.1.8 Alignment and Field Errors
 - 3.1.9 Insertion Device Modeling
 - 3.1.10 Optical Upgrade Paths
 - 3.1.11 Coupling and Correction
 - 3.1.12 Beam-Stay-Clear
 - 3.1.13 Photon Beam Steering Envelope
 - 3.1.14 Lattice Commissioning
 - 3.1.15 Lattice Tuning
- 3.2 Injection
 - 3.2.1 Beam Transfer Line
 - 3.2.2 Injection Bumps
 - 3.2.3 Injection Analysis

- 3.3 Beam Stability Requirements
 - 3.3.1 Transverse Stability Requirements
 - 3.3.2 Longitudinal Stability
 - 3.3.3 Beam Stabilization Plan
- 3.4 Orbit Control
 - 3.4.1 Sources of Orbit Distortion and Motion
 - 3.4.2 BPM and Corrector Locations
 - 3.4.3 Orbit Correction Algorithms
 - 3.4.4 Static Orbit Control
 - 3.4.5 Dynamic Orbit Control
 - 3.4.6 Quadrupole Field Modulation
- 3.5 Storage Impedance
 - 3.5.1 RF Cavities
 - 3.5.2 Chamber Impedance
 - 3.5.3 Power Loss Estimates
 - 3.5.4 Impedance Budget Conclusions
- 3.6 Collective Effects and Stabilization 3.6.1 Single Bunch Thresholds Multibunch Motion and Stabilization 3.6.2 3.6.3 Conclusions 3.7 Beam Lifetime Quantum Lifetime 3.7.1 **Gas Scattering Lifetime** 3.7.2 3.7.3 Intra-beam Scattering 3.7.4 Total Electron Beam Lifetime 3.8 Ion and Dust Effects Machine Parameters 3.8.1 Ion Production Rates and Ion Densit 3.8.2 Trapping 3.8.3 Lifetime 3.8.4 Tune Shift 3.8.5 Ion Frequencies 3.8.6 Coherent Trapped-Ion Instabilities ar 3.8.7 Fast Beam-Ion Instability 3.8.8
 - 3.8.9 Dust Trapping







SPEAR3 Lattice



Beam-Stay-Clear







SPEAR3 Lattice – Orbit Correctors and BPMs



BPM locations

(104 total; 90 used for orbit feedback)





SPEAR 3 Lattice Properties





Multi-Objective Genetic Algorithms (MOGA, D. Robin et al.)



Narrowband

No harmful HOMs from PEP-II cavities No feedback needed for coupled bunch instabilities

Broadband

 $L_{tot} = \sim 120 \text{ nH}$ $Z/n = \sim 1 \Omega$ $f_R = 15 \text{ GHz}$

 $I_{th} = 5$ mA/bunch for onset of energy widening

~x2 energy and bunch widening at 25mA/bunch

Resistive Wall

Tunes below half integer $I_{th} @ 0.2 \xi$ (norm): (head-tail damping)

450 mA for SS chamber>800 mA for Cu chamber





Bunch Length and Energy Spread vs. Current







Lifetime

Gas Scattering: 28 h @ 500 mA

- Coulomb: 89 h
- Bremsstrahlung: 41 h

1.8 nTorr N_2 -equivalent (conservative), 3% energy acceptance

Touschek: 53 h @ 500 mA

1% coupling, 3.2 MV RF, 3% energy accept, 279 bunches

Total: 18 h @ 500 mA

- higher if pressure <1.8 nTorr
- 45 h @ 200 mA





Gas Scattering Lifetime

Beta-pressure profile:





Coulomb lifetime and vertical aperture:



Total gas-scattering lifetime:





Touschek Lifetime and Momentum Acceptance



Double-Waist Chicane Optics (BL 12, BL 13)





Chicane Optics

Baseline optics

matching straight, $\beta_y = 4.8$ m long straight, $\beta_y = 10$ m

Chicane optics

matching straight, β_y = 2.5 m

long straight, $\beta_v = 1.6$ m



















mode-damped rf cavities











low-impedance chambers

mode-damped rf cavities














SPEAR 3 Magnet Girders

SPEAR2 girders:



SPEAR 3 option 1:



SPEAR 3 option 2 (selected, new concrete floor):



TPS Girder Mover System



• The side pillar moved to the top of one pedestal to release clumsy space



TPS

- Tilting moved to the center area of girder for better reference
- Touching sensors adopting LVDT for cost down and small reference sockets on the sensor modules for better installation accuracy (<10μm)



NSLS-II and MAX-IV Magnet Girders



NSLS-II





NSLS-II and MAX-IV Magnet Girders



Magnet Types in a Typical Cell







Dipole Types

- Dipole straight and curved (more expensive), depending on sagitta
- Gradient dipole (for compact lattices)
- Variable field dipole

e.g. LNLS2: low field permanent magnet, high field at beam line source point









Injection Septum Magnets

• Vertical injection – Lambertson septum magnet



PLS-II septum magnet







Injection Septum Magnets

• Vertical injection – Lambertson septum magnet







• Horizontal injection - thick and thin septa









Magnetic Measurement





NSLS-II









$$B(z) = \sum (B_n + iA_n) z^{n-1}, \ z = x - iy$$





A curve from Klaus Halbach's paper, *First Order Perturbation Effects in Iron-Dominated Two-Dimensional Symmetrical Multipoles*, published in *Nuclear Instruments and Methods* – *Volume 74 (1969) No. 1* is reproduced above. It describes the effects on the first three *allowed* multipole errors of radial offset portions of a pole for a quadrupole.





SPEAR3 Vacuum Chamber





Stable BPM Supports









Shielded Bellows



NATIONAL

ACCELERATOR

LABORATOR



ID Mis-Steer Interlock





Aluminum Vacuum Chamber – PLS-II







FMB Feinwerk- und Meβtechnik GmbH Rudower Chaussee 6, Geb. 19.26/27 D-12484 Berlin (Germany)





Vacuum Chamber - Dipole and Sextupole (ANKA / Karlsruhe)

Radius (Dipol Chamber): 5559 mm Total length: 2847 mm

Minimal Chambers: NEG-coated (MAX-IV)



Fig. 1. (Color online) The vacuum system of cell 2 and cell 3 in the MAX II storage ring from a) commissioning to July 2007, b) July 2007 to July 2008, c) July 2008 to April 2009 and d) from April 2009 onwards.





Mitigation of Resonance Modes in Chamber – RF Shields

TE₁₁ mode in wide chamber near BPM @ ~500 MHz processing frequency



NSLS-II: flexible BeCu RF fingers with 50% of opening space







Straight Section Chambers



Diagnostics

• Bergoz DCCT, 1 μ A in 1 second







• Stripline tune driver

NATIONAL ACCELERATOR LABORATORY





0.5 second DCCT data

Tune measurement



In-Flange DCCT: Bergoz NPCT







NSLS-II Diagnostics Systems

Systems	NSLS-II				Vendor		
	SR		BTS	LTB	Booster	Linac	Gun
RF BPM – Single Pass			8	6		5*	
RF BPM – TBT & Stored Beam	180				37*		
ID RF BPM	2 or 3 per l	D					
Fill Pattern Monitor (WCM)						3	2
Fill Pattern Monitor (FCT or SL)	1		2	2	1		
Faraday Cup			1	2			1
Beam Charge Monitor (ICT)			2	2			
Fluorescent / OTR Screen	3		9	9	6	6	
Energy Slit			1	1			
Photon BPMs	1 or 2 per l	D					
Stored Beam monitor (DCCT)	1				1		
Tune Monitor	1				1		
Top-Off Monitor	2						
X-Ray Diagnostics (BM-A Source)	1						
X-Ray Diagnostics (3PW Source)	1						
VSLM Diagnostics (BM-B Source)	1				1		
Transverse Feedback (H & V)	1+1						
Beam Loss Monitors	TBD						
Beam Scrapers (H & V)	3+2						





Power Supplies



large power supplies

dipole choppers (1







intermediate supplies (10-15 kW)





bipolar power supplies



30 A bipolar supply crate

RF HVPS (15 kV)



Power Supplies – NSLS-II

Power Supply -Model	Qty	Max. Voltage	Max Current	Configuration	Stability / Resolution ppm of max I	Operation
Main Dipole	1	1200 V	450 A	Unipolar Switch-Mode , Digital Regulator center point tied to GND	25 3.8	DC 1 Quadrant
Quadrupole -A -B -C -D	60 120 60 60	16 V 22 V 30 V 30 V	175 A 175 A 175 A 200 A	Unipolar Switch-Mode Analog Curr. Regulator – 2 DCCTs 1 PS per Magnet	50 3.8	DC 1 Quadrant
Sextupole -A -B -C	40 5 12	40 V 60 V 16 V	120 A 165 A 120 A	Unipolar Switch-Mode Analog Curr. Regulator- 2 DCCTs Model A & B = 1 PS per 6 Magnets Model C = 1 PS per 2 Magnets	100 15 (3.8)	DC 1 Quadrant
Global Horz. & Vert. Correctors -A	90	24 V	1.25 A	2 Channel Bipolar Linear Analog Curr. Regulator - 4 Shunts	100 15 (3.8)	2000 Hz 4 Quadrant
Insertion Horz. Correctors -B	12	30 V	30 A	Unipolar Switch-Mode Analog Curr. Regulator – 2 DCCTs	50 3.8	DC 1 Quadrant
Skew Quad Corrector-C	30	20 A	20 A	Bipolar Linear Analog Curr. Regulator – 2 DCCTs	100 15 (3.8)	DC 4 Quadrant
Alignment Horz. & Vert. Correctors -D	180	25 V	22A	2 Channel Bipolar Linear / Pre-Regulator Analog Curr. Regulator - 4 DCCTs	25 3.8	3 Hz 2 Quadrant
Dipole Trim – Corrector -E	27	15V	4 A	2 Channel Bipolar Linear / Pre-Regulator Analog Curr. Regulator – 4 DCCTs	100 15 (3.8)	DC 4 Quadrant
Dipole Trim – Corrector -F	3	20 V	10 A	2 Channel Bipolar Linear / Pre-Regulator Analog Curr. Regulator – 4 DCCTs	100 15 (3.8)	DC 4 Quadrant

There is a total of 997 power supply channels used for the NSLS-II storage ring





Magnet family power supplies: "strings" vs. individual

- Quadrupoles need individual tuning to correct for ID focusing effects
- Quadrupole modulation is desired for beam-based alignment and BPM calibration (trim coils can be used for series-powered families)
- Recent studies show that best dynamic aperture may be reached with independently tuned sextupoles (normally powered in families)
- Individual power supplies + cabling usually cost more than strings, but this cost difference can be reduced with modular power systems and short cable distances





Fast Corrector Power Supplies - SPEAR3



MCOR 30 crate

MCOR 30 and controller daughter card





rear panel Frankenbride board

> MCOR control Frankenboard + VME CPU

CDEAD 2 Design



NATIONAL ACCELERATOR LABORATORY



SPEAR 3 RF System







SPEAR 3 RF System - cont



circulator



waveguide network









SPEAR 3 RF System - cont



circulator



1.2 MW klystron

ATIONAL ACCELERATOR LABORATOR



waveguide network installed cavities







low level RF control

ALBA Mode-damped RF Cavity

Cavity			Waveguide dampers	RF-coupling windo
f	499,654	MHz		· · ·
Q	27000			1
Rshunt	3.1	MΩ		1
R/Q	115	Ω		×
Cavity power	60	kW	Tuner	No.
Beam power/cav	87	kW		
IPC power	147	kW	Beam pipe -	
Type of cavity	nc (6 Cel	Is/IPC)		
Total Voltage	3.6	MV (60	0 kV / cell)	1 - W
Total Power	960	kW (16	0 kW / cell)	

•The Call for Tender process is starting now. A prototype with improvements respect the original BESSY design will be first produced.

•A SC third harmonic cavity is planned







Superconducting RF Cavity





Two CESR-type cryomodules in a long-straight section.

Superconducting RF – Cryogenic System







SCRF – Klystrons and Solid State Amplifiers

300kW HPRF Klystron-TH2161B



- Frequency; 500MHz
- RF Output(CW); 300kW
- Gain; 40dB(min)
- Efficiency; 63%(typ)
- Heater; 10V/30A
- Beam voltage/current;

54kV/10.

- Anode volt
- Ion Pump
- Magnet(fos 100V/1;
- Water cooing 450 liter/n
 Water coolin
- 10 liter/m
- Air cooling f
- Air cooling f



190 kW @ 352 MHz Gain = 52 dB Overall Efficiency (PS,..) ~50% No RF trip even if transistor fails

Laurent S. Nadolski

SSRL seminar, April 30th 2007





Digital LLRF Control

- Gone through 2 revisions
- Addition of integrated -RF-IF up/down conversion,
- Enhanced device cooling,
- Standard 1U 19" chassis packaging,
- 4 samples are being made for supporting RF development tasks.





SPEAR3 Instrumentation and Control





7-68 8413A106
SPEAR3 Instrumentation and Control







7-68 8413A106

SPEAR3 Instrumentation and Control

- 10⁷ bytes/sec real-time data rates
- 10⁶ process variables
- 4 x 10³ Hz orbit acquisition
- 10² Hz orbit feedback
- 10 Hz injection
- < 5 x 10^{-3} sec protection from beam mis-steer
- < 10⁻⁶ meter beam position control







7-68 8413A106

Control System Architecture

Configuration Diagram of PLS-II Control







MATLAB Application Programs



SPEAR3 Timing and RF Signal Generator System



Modern EVG/EVR Timing System

Event Trigger System

- Collaboration with SSRF
- 1 EVG IOC, 15 EVR IOCs
- All hardware modules are under procurement







Fast Global Orbit Feedback System

Rate:	4kHz
Bandwidth:	~200 Hz
Number of BPMs:	112 x + 112 y (capable) , 53 x + 53 y now
Number of Correctors:	72 x + 72 y (capable) , 54 x + 54 y now
Control Algorithm:	SVD, PI in the singular vector space of the response matrix





Fast Global Orbit Feedback System

Rate:	4kHz
Bandwidth:	~200 Hz
Number of BPMs:	112 x + 112 y (capable) , 53 x + 53 y now
Number of Correctors:	72 x + 72 y (capable) , 54 x + 54 y now
Control Algorithm:	SVD, PI in the singular vector space of the response matrix

Static orbit correction

$\Delta \overline{\mathbf{x}} = \mathbf{R} \Delta \overline{\mathbf{\theta}}$	<i>R</i> =	$= USV^T$		
$\Delta \overline{\Theta} = V S^{(-1)} U^T \Delta \overline{x}$				
orbit correction eigenvectors	inverse singular values	orbit BPM eigenvectors		





Fast Global Orbit Feedback System

Rate:	4kHz
Bandwidth:	~200 Hz
Number of BPMs:	112 x + 112 y (capable) , 53 x + 53 y now
Number of Correctors:	72 x + 72 y (capable) , 54 x + 54 y now
Control Algorithm:	SVD, PI in the singular vector space of the response matrix



Dynamic orbit correction

$$\Delta \overline{\Theta}(t) = V \hat{K}_{PI} S^{(-1)} U^T \Delta \overline{x}(t)$$
$$\hat{K}_{IP} \overline{a}(t) = K_I \sum_{n=0}^{\infty} \overline{a}(t-n) + K_P \overline{a}(t)$$



BPM Processing and Orbit Feedback System







SPEAR 3 BPM Processors







Fast Orbit Feedback Performance

- Large improvement for ½ second averaged BPM data
- ~200 Hz bandwidth,









SPEAR Orbit Distortion

Distributed perturbations from small uncorrelated (~1µm) vibrations of individual magnets and supports cause orbit distortions that are concentrated in the eigenmodes having large singular values







Dispersion Orbit Correction with RF Feedback





Table 3.28 Effect of circumference change induced by 1° C temperature rise in various materials.

Material	K [*C-1]	ΔL [mm]	Δp/p [%]	Δx [mm]	Δf [kHz]
Copper	16x10-6	3.75	1.411	6.69	-5.726
Stainless steel	7x10-6	3.98	1.465	6.96	-6.076
Aluminum	24x10-6	5.85	2.205	10.45	-8.932
Iron	12x10-6	2.81	1.058	5.01	-4.290



÷



Floor Motion Study - Hydrostatic Level System

(G. Gassner – SLAC, http://www-group.slac.stanford.edu/met/Align/Spear3/SPEAR_WWW/nov05/autoplot.html)









Floor Motion Study - Hydrostatic Level System

(G. Gassner – SLAC, http://www-group.slac.stanford.edu/met/Align/Spear3/SPEAR_WWW/nov05/autoplot.html)







Date

Mirror Pitch Feedback (SSRL, T. Rabedeau)

- error signal obtained from position sensitive (split) detector located near beam focus
- error signal used to control piezo high voltage via PI algorithm
- piezo provides mirror fine pointing control with typical full range of motion +/-~30 μrad



SPEAR 3 Beam Line Components



BL Tront end mask



wheel-in BL front end



SPEAR 3 LN Monochromator + Crystal Exchange



SPEAR3 Insertion Devices

Beam Line	Device	Periods	Field (T)
4	PMW	10	2 @ 16 mm
5	EPU	26	0.7 @ 18.6 mm
6	PMW	27	0.9 @ 16 mm
7	PMW	10	2 @ 16 mm
9	PMW	8	1.9 @ 24 mm
10	PMW	15	1.3 @ 24 mm
11	PMW	13	2 @ 16 mm
12-2	IVUN	67	1.1 @ 5.5 mm
13	EPU	65	0.8 @ 13.5 mm
12-1(future)	TBD		
future (4)	TBD		









"Magic fingers" used to correct dynamic integrals for BL11 ID (poles too narrow)







"Magic fingers" used to correct dynamic integrals for BL11 ID (poles too narrow)



 1st and 2nd second integrals, transverse field roll-off now fully specified for ID vendors



For BL12 & 13: 100 + 50' [x] G'cm, [x] <2.5 cm; (ALS extended to 25 mm)





• "Magic fingers" used to correct dynamic integrals for BL11 ID (poles too narrow)



- 1st and 2nd second integrals, transverse field
- Skew quad errors found in EPUs corrector
 Skew quad to BL5 and BL13 EPUs



For BL12 & 13: 100 + 50'|x| G'cm, |x|<2.5 cm; (ALS extended to 25 mm)





"Magic fingers" used to correct dynamic integrals for BL11 ID (poles too narrow)





- 1st and 2nd second integrals, transverse field roll-off now fully specified for ID vendors
- Skew quad errors found in EPUs corrector coils added to BL5 and BL13 EPUs
- EPU field integrals partially corrected by shimming



For BL12 & 13: 100 + 50' |x| G'cm, |x|<2.5 cm; (ALS extended to 25 mm)





"Magic fingers" used to correct dynamic integrals for BL11 ID (poles too narrow)



- 1st and 2nd second integrals, transverse field roll-off now fully specified for ID vendors
- Skew quad errors found in EPUs corrector coils added to BL5 and BL13 EPUs
- EPU field integrals partially corrected by shimming
- IDs symplectic integrator included in AT accelerator modeling (Wu et al., Phys. Rev. E, 2003) For BL12 & 13: 100 + 50"[x] G*cm. [x] < 2.5 cm; (ALS extended to 25 mm)





Dynamic integr

Residua



SPEAR 3 Commissioning

First beam to SPEAR3: First turn: First stored beam: 100 mA: First beam seen in beam line: First users: Dec. 10. 2003 Dec. 12 Dec. 15 Jan. 22, 2004 Mar. 8 Mar. 15













Topics Not Discussed

- Injector design
- Kicker magnets and pulsers
- Synchrotron light monitors
- Photon BPMs and misc. other diagnostics
- Transverse/Longitudinal Feedback Systems
- Machine Protection Systems
- Personnel Protection Systems
- Beam Containment Systems
- Radiation shielding
- Tunnel and experimental floor engineering
- Utilities (gasses, water, electricity)





Beam energy	3 GeV	
Injection energy	3 GeV	
Current	100-500 mA	
Fill pattern	280 bunches, 93-bunch gap, camshaft bunch in gap (6-bunch timing mode @ 100 mA available)	
Circumference	234.144 m	
Radio frequency	476.315 MHz	
Bunch spacing	2.1 ns	
Horizontal emittance	10 nm*rad	
Vertical emittance	14 pm*rad	
Critical energy	7.6 keV	
Energy spread	0.097%	
Lifetime	~50 h @ 100 mA, ~14 h @ 500 mA	
e- size (x,y)	Dipole: 140, 14 µm rms Standard ID: 310, 8 µm rms Chicane ID: 300, 5 µm rms	
e- divergence (x,y)	Dipole: 180, 2.9 µrad rms Standard ID: 33, 1.7 µrad rms Chicane ID: 34, 2.9 µrad rms	
Bunch length	20 psec rms (6.7 mm rms)	
 Churchet another a fam IDa	9 x 2.3 m	



Straight sections for IDs (available ID length)

9 x 2.3 m 4 x 3.7 m 2 x 1.5 m (Chicane)

